

■ IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 282

Examiner: C

Date: January 28, 2002

n re Application of:

H. WATANABE et al.

Serial No.: 09/320,271

Filed: May 27, 1999

For: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREOF

PETITION FOR EXTENSION OF TIME

Commissioner for Patents Washington, D.C. 20231

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated September 27, 2001, for one month from December 27, 2001 to January 28, 2002 (January 27 was a Sunday).

Attached please find a check in the amount of \$110.00 to cover the cost of the extension. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. This paper is filed in triplicate.

01/29/2002 MGEBREM1 00000037 09320271

02 FC:115

110.00 OP

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

hen G. Adrian

Reg. No. 32,878

Atty. Docket No. 990559 1725 K Street, N.W., Suite 1000 Washington, DC 20006

Tel: (202) 659-2930 Fax: (202) 887-0357

SGA/arf